

PATENT
450100-04421

#2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tomohisa SHIGA
International Application No.: PCT/JP03/03716
International Filing Date: March 26, 2003
For: OPERATION-PROCESSING DEVICE, METHOD FOR
CONSTRUCTING THE SAME, AND OPERATION-
PROCESSING SYSTEM AND METHOD

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Date of Deposit: September 23, 2004

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INFORMATION DISCLOSURE STATEMENT

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Sir:

Enclosed are copies of the publications, which were cited in the International

Search Report of International Application No. PCT/JP03/03716. Also enclosed is a copy of

Form PTO-1449 and the International Search Report.

10/508802

DT12 Rec'd PCT/PTO 23 SEP 2004

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REMARKS

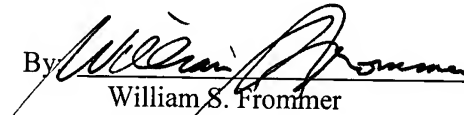
Entry of this Information Disclosure Statement and an early examination on the merits are respectfully solicited.

Please charge any additional fees to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP
Attorneys for Applicant

By



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Enclosures

Based on Form PTO-1449 (3/90)				ATTY. DOCKET NO. 450100-04421		SERIAL NO. Filed Concurrently Herewith	
LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Tomohisa SHIGA			
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U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
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FOREIGN PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
	AL	WO 00/19329	04/06/00	PCT			
	AM	JP 2000-105759	04/11/00	Japan			
	AN	JP 5-55907	03/05/93	Japan			
	AO	JP 4-91519	03/25/92	Japan			
	AP	JP 10-320172	12/04/98	Japan			

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)			
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